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**APPLICANTS**  
 Masashi Kawasaki, Miyagi, JAPAN;  
 Akira Ohtomo, Miyagi, JAPAN;  
 Tomoaki Fukumura, Miyagi, JAPAN;  
 Atsushi Tsukazaki, Miyagi, JAPAN;  
 Makoto Ohtani, Miyagi, JAPAN;

**\*\* CONTINUING DATA \*\*\*\*\***  
 This application is a 371 of PCT/JP04/13246 09/10/2004

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***  
 JAPAN 2004-031194 02/06/2004

**\*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\* \* SMALL ENTITY \*\***  
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Foreign Priority claimed 35 USC 119(a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No /JOEL G HORNING/ Examiner's Signature	<input type="checkbox"/> Met after Allowance Initiate	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 10	TOTAL CLAIMS 13	INDEPENDENT CLAIMS 3
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**ADDRESS**  
 DICKSTEIN SHAPIRO LLP  
 1825 EYE STREET NW  
 Washington, DC 20006-5403  
 UNITED STATES

**TITLE**  
 Method of Manufacturing Thin Film, Method of Manufacturing P-Type Zinc Oxide Thin Film and Semiconductor Device

<b>FILING FEE RECEIVED</b> 1425	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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